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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Attorney Docket Number	5437-60780-01		
Application Number	09/921,993		
Filing Date	August 2, 2001		
First Named Inventor	Scarborough		
Art Unit	2129		
Examiner Name	Lut Wong		

U.S. PATENT DOCUMENTS

Copies of U.S. Patent documents do not need to be provided, unless requested by the Patent and Trademark Office. For patents, provide the patent number and the issue date. For published U.S. applications, provide the publication number and the publication date. For unpublished pending patent applications, provide the application number and the filing date.

Examiner's Initials*	Cite No. (optional)	Number	Publication Date	Name of Applicant or Patentee
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EXAMINER	DATE
SIGNATURE:	CONSIDERED:
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^{*} Examiner: Initial if reference considered, whether or not in conformance with MPEP 609. Draw line through cite if not in conformance and not considered. Include copy of this form with next communication to applicant.

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				Filing Da	te	August 2, 2001
			First Named Inventor		_	
			Art Unit		2129	
				Examiner	Name	Lut Wong
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